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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

January 21, 2026

IGI Report Number **LG766664680**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.43 X 7.21 X 4.47 MM**

GRADING RESULTS

Carat Weight **2.10 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG766664680**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

LG766664680
Report verification at igi.org

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LG766664680

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Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.43 X 7.21 X 4.47 MM**

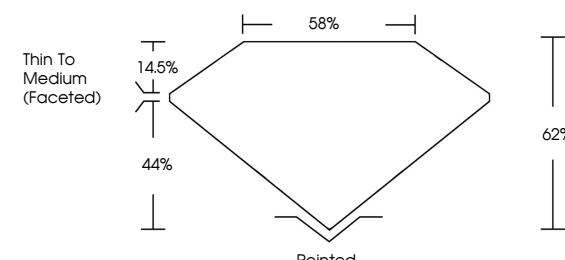
GRADING RESULTS

Carat Weight **2.10 CARATS**

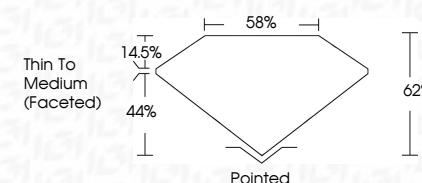
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	SI ¹⁻²	SI ¹⁻³	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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ADDITIONAL GRADING INFORMATION

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January 21, 2026	IGI Report No LG766664680
	OVAL BRILLIANT
	10.43 X 7.21 X 4.47 MM
	2.10 CARATS
	D
	VVS 2
	62%
	Thin To Medium (Faceted)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	IGI LG766664680

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